

<b>Notice of References Cited</b>	Application/Control No. 09/635,832	Applicant(s)/Patent Under Reexamination YAMAZAKI ET AL.	
	Examiner Fernando L. Toledo	Art Unit 2823	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf and Tauber; "Silicon Processing for the VLSI Era Volume 1: Process Technology"; pages 242-248; 1986; Lattice Press; Sunset Beach, CA
	V	Levine, Ira N.; "Physical Chemistry"; Fourth Ed.; pages 465-467; 1995; McGraw Hill, Inc.; New York, NY
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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